



## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takatoshi TSUCHIYA et al.

Group Art Unit: 2853

Application No.: 10/721,353

Examiner:

L. MARTIN

Filed: November 26, 2003

Docket No.:

117059

For:

SYSTEMS AND METHODS FOR VENT PATH LEAKAGE PREVENTION

## AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the September 29, 2005 Office Action and the November 21 personal interview, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.